

RÅC Perspective Workshop – Photon Science
Hamburg 9/6, 2017

In situ and in operando
high-energy X-ray characterization of
hard protective tool coatings

Jens Birch
Thin Film Physics division
Linköping University

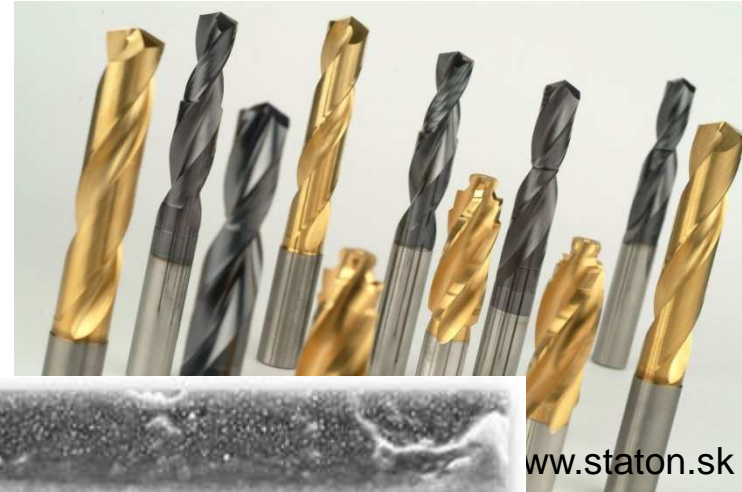
Norbert Schell
High Energy Materials Science Beamline
Helmholtz-Zentrum Geesthacht

Coated cutting tools

Important for Sweden & Germany!

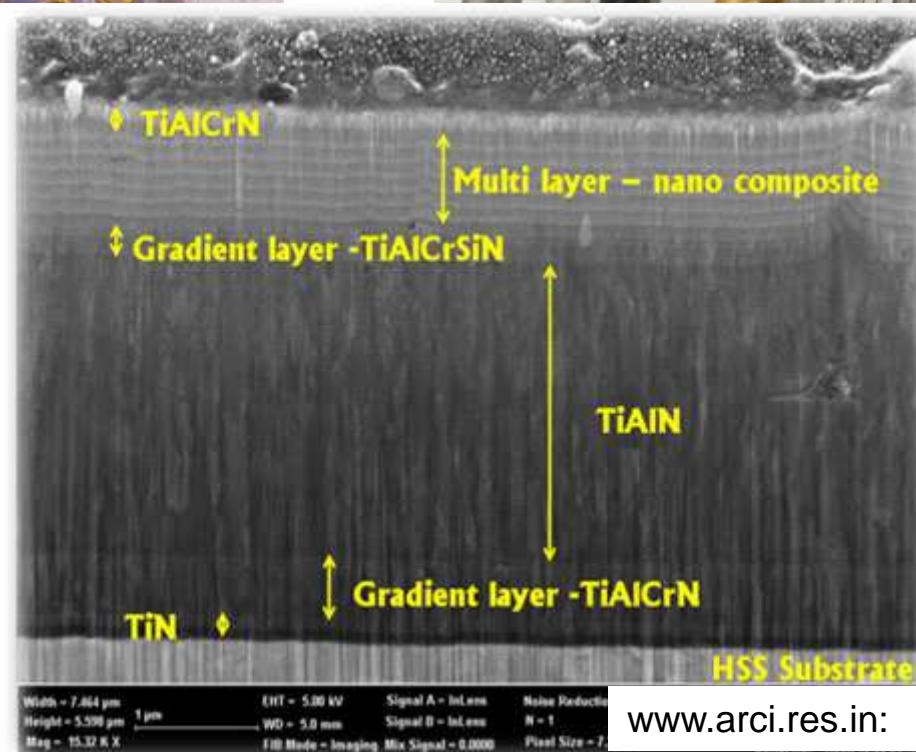


Cutting inserts



www.staton.sk

and drills



Coated cutting tools

Important for Sweden & Germany!



Cutting inserts



Mills and drills

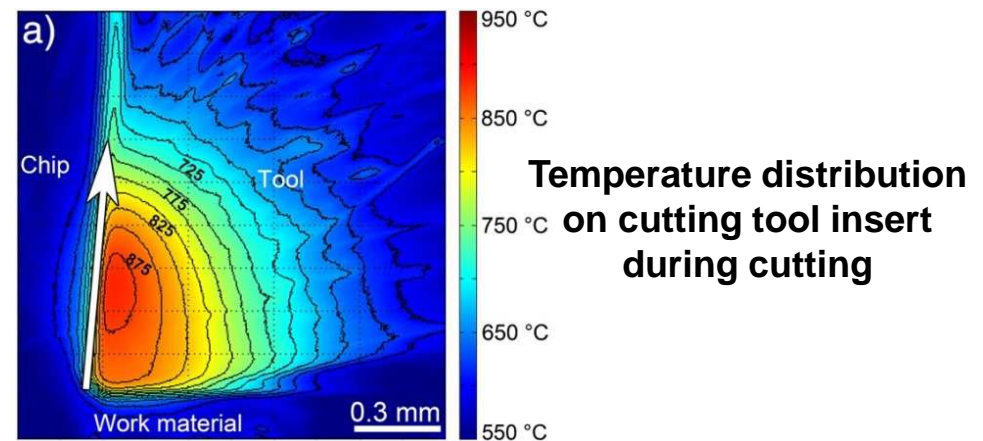
High speed dry cutting



Higher productivity
No cooling liquids



Hotter tools!



The “X-Cut” project

**“Materials Science of High Performance Cutting Tool Coatings
by use of
in-situ High Energy X-ray Scattering”**

Beam Line P07 at Petra III - “High Energy Materials Science” HEMS

Materials Science of Thin Films

Cutting Tool Manufacturer

Money

The “**X-Cut**” project

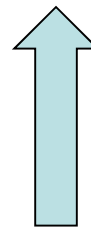
*In-situ high energy **X-ray** scattering during the **Birth and Death of Cutting Tool Coatings***

Beam Line P07 at Petra III - “High Energy Materials Science” HEMS

Materials Science of Thin Films



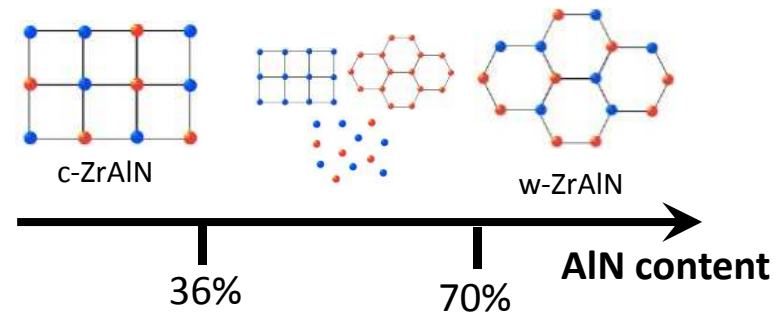
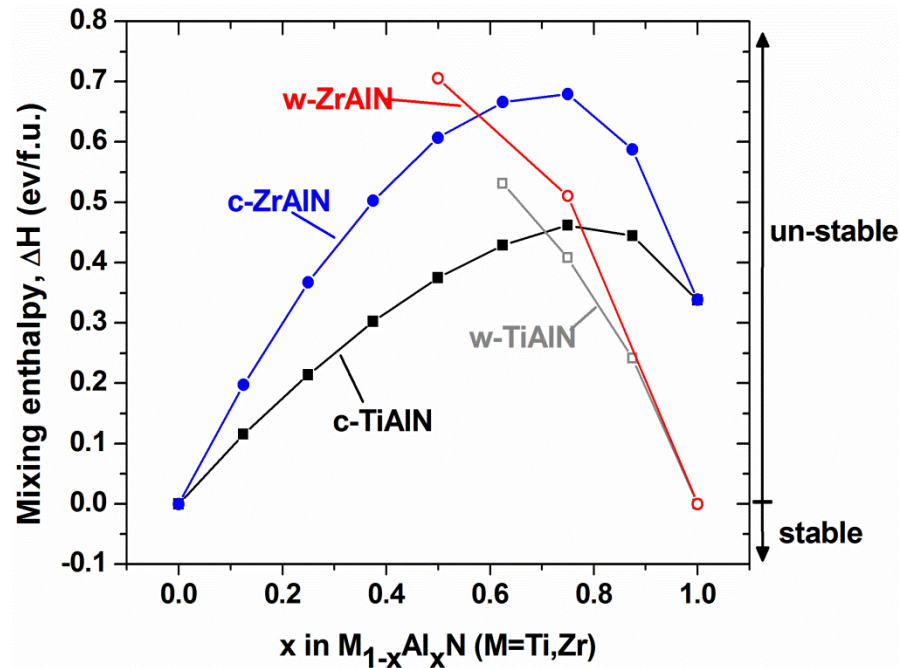
Cutting Tool Manufacturer



Money



Stability of metastable hard coatings



Future's workhorse hard coatings

ZrAlN?

TiNbAlN?

CrTiAlN?

...

Formation?

Phase transitions?

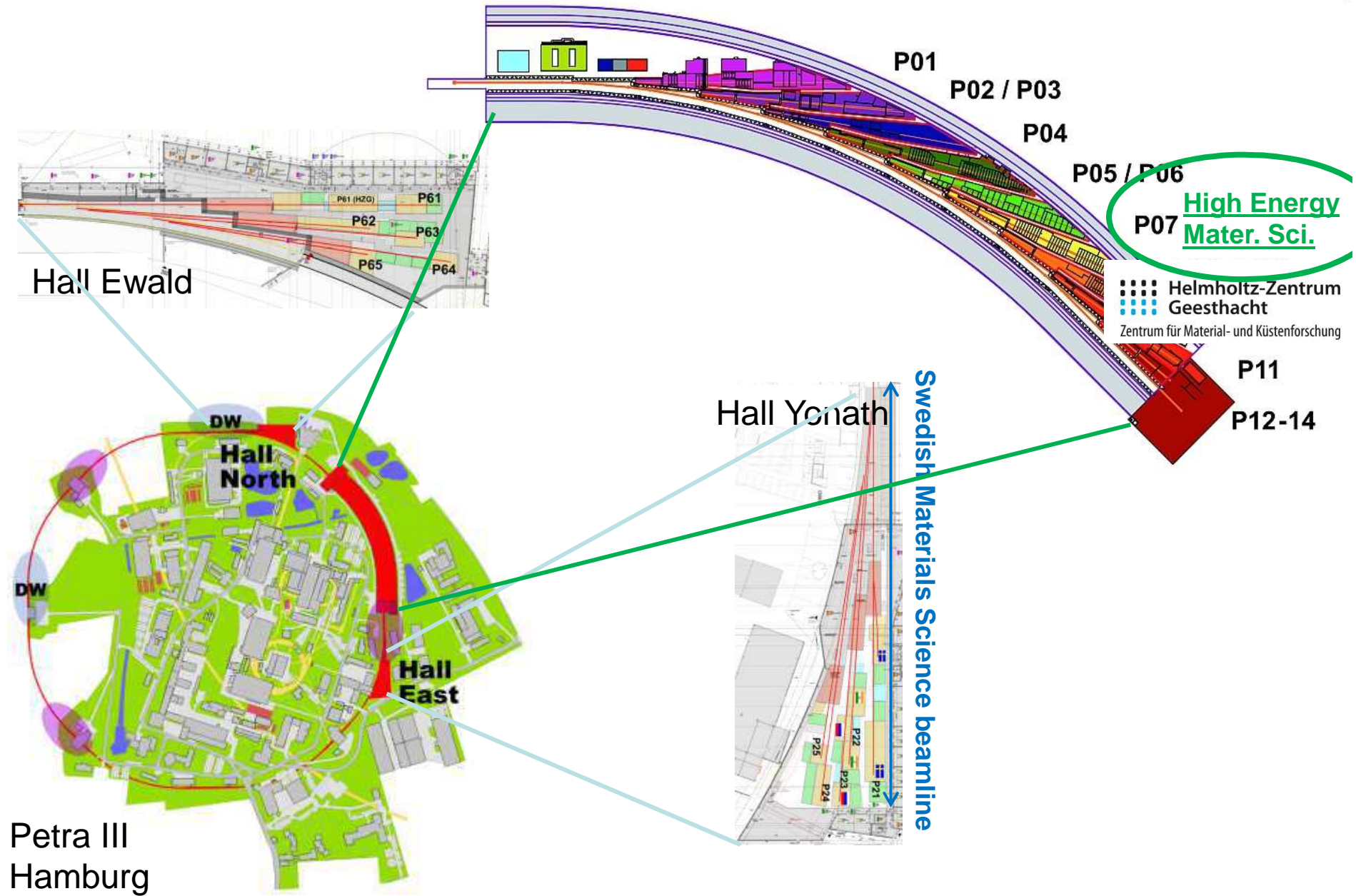
Coating stability?

Substrate interactions?

Alling *et al.*, Appl. Phys. Lett. **95** (2009) 181906.

L. Rogström *et al.*, J. Vac. Sci. Technol. A **30** (2012) 031504.

High Energy Materials Science Beamline at Petra III



Advantages of High Energy X-rays for Materials Science

- **High penetration depth**

- ✓ Non-destructively bulk properties measurable
- ✓ Deeply buried structures accessible
- ✓ Easy to design special-purpose in-situ equipment (growth, catalysis, HP, strain, ...)

- **Large Ewald's Sphere in scattering experiments**

- ✓ Small Bragg angles (5° to 15°) → complete diffraction rings @ area detectors
- ✓ Wide-angle- and Small-angle X-ray scattering (WAXS & SAXS) simultaneously
- ✓ Large range of lattice planes can be probed simultaneously

- **Focussing to spot sizes in nm range possible**

- ✓ High spatial resolution
- ✓ Combination of high penetration depth and high flux
- ✓ Very short data acquisition times possible

- **High intensity**

- ✓ Time-resolved data → 2D area detector read out at 0.1-100 Hz
- ✓ Non-destructive observation of dynamic processes

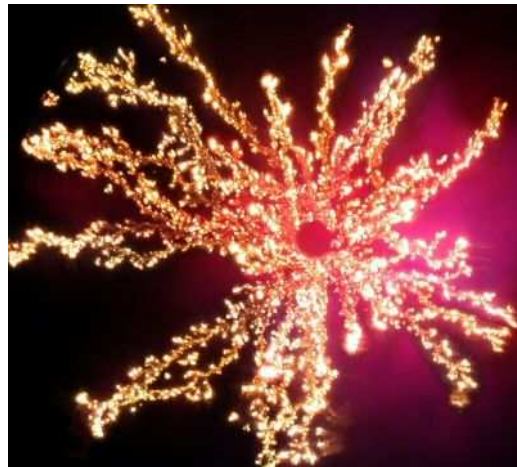
Birth of the coatings

- HT Chemical Vapour Deposition - CVD



- Physical Vapour Deposition – PVD

- Cathodic Arc Deposition

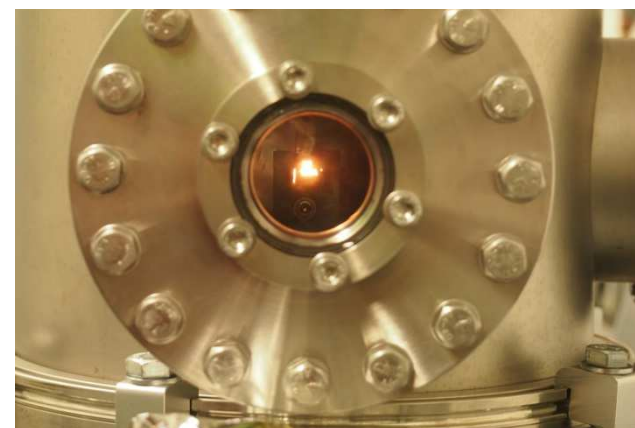
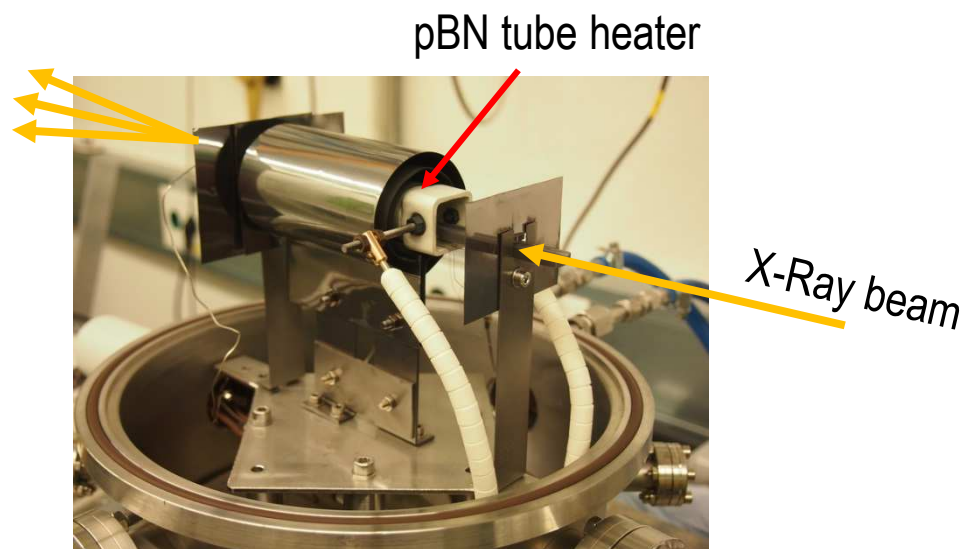
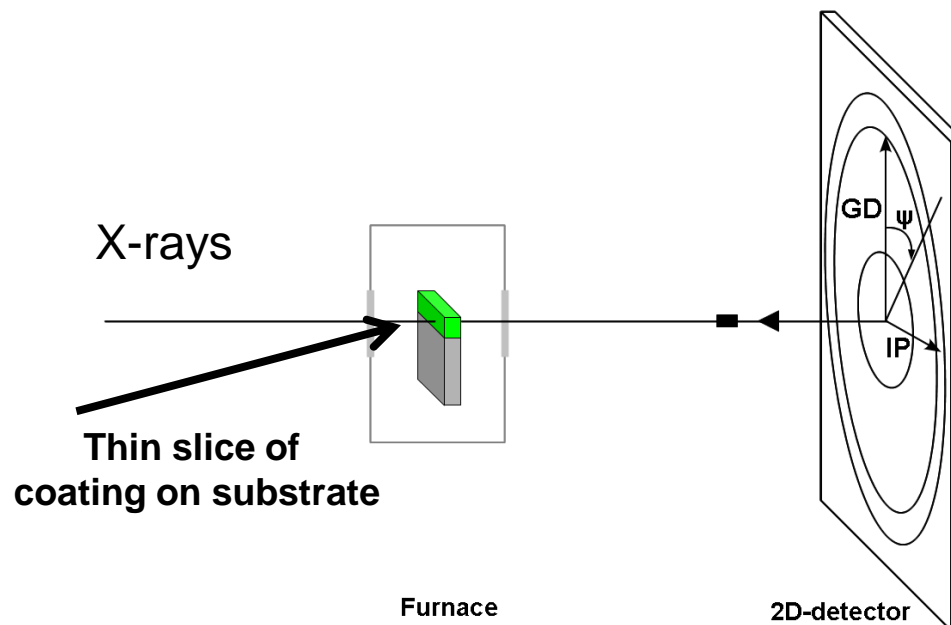


- Magnetron Sputter Deposition

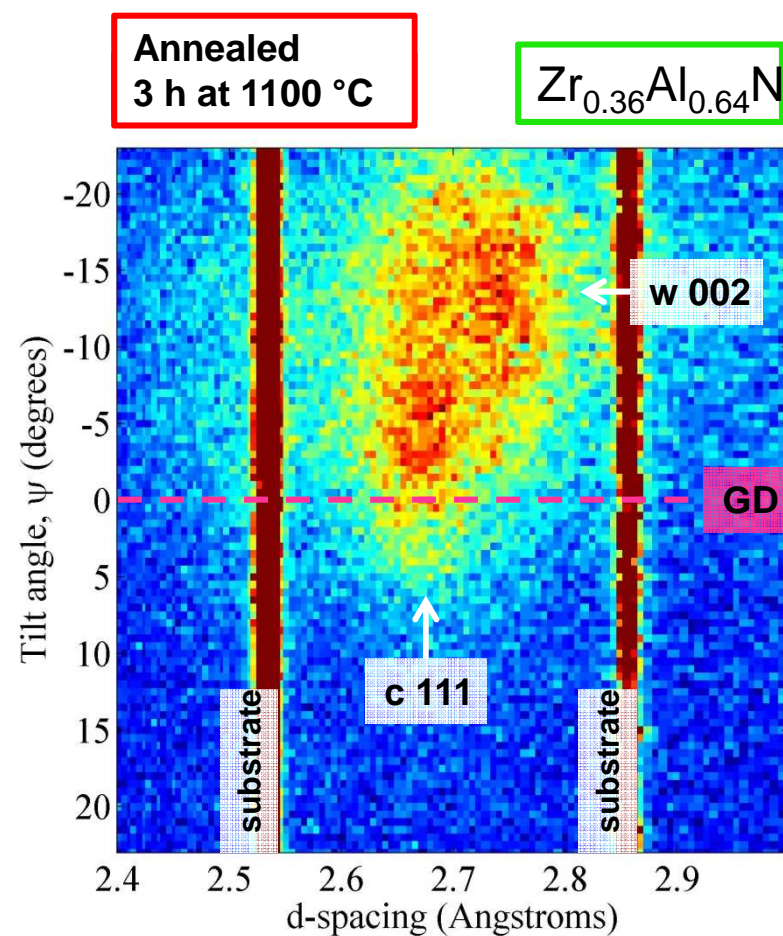
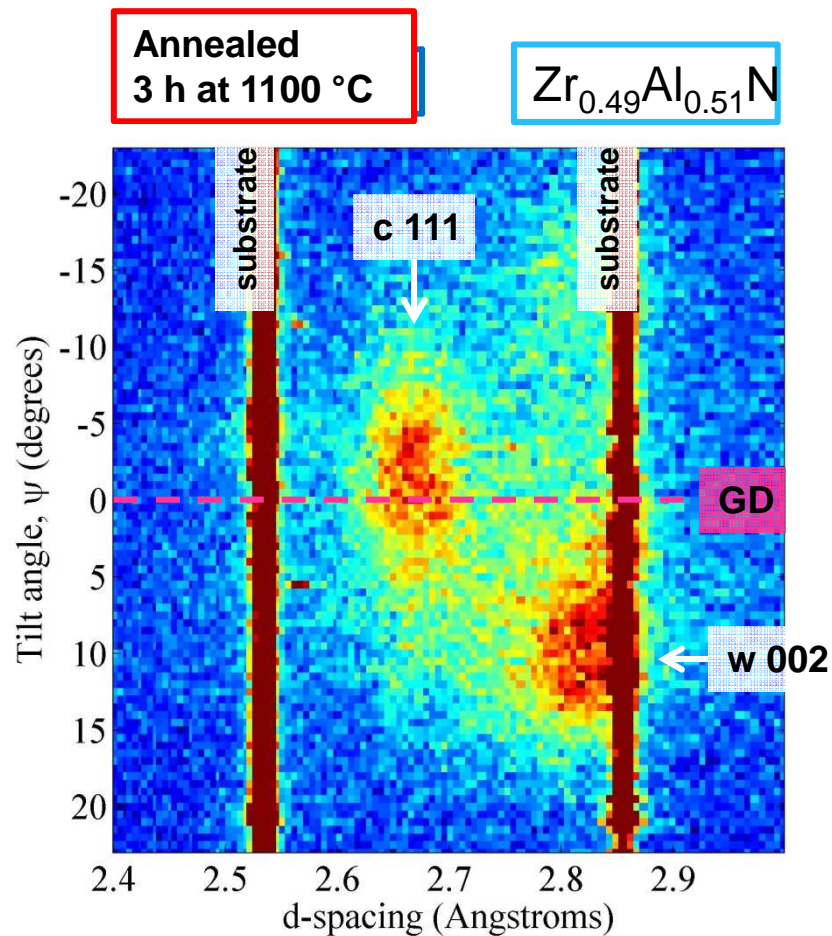
High vacuum furnace for *in situ* high energy x-ray scattering during film formation/decomposition

Capabilities:

- >1100 °C
- Large uniform heating zone
- Inert atmosphere
- Simple sample alignment
- Off-beamline capability
- Portable



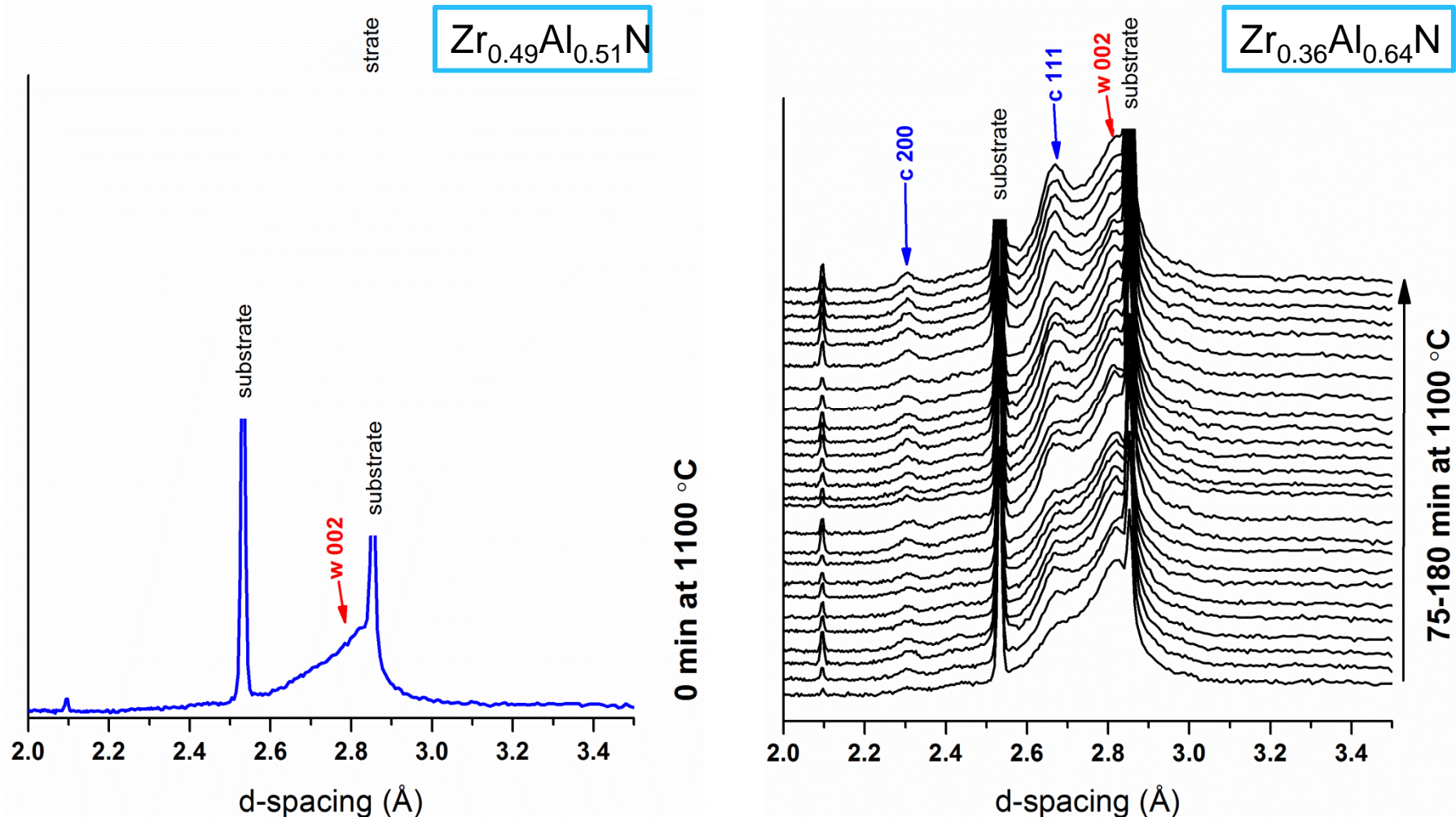
In situ WAXS during annealing of w-ZrAlN coatings (X-ray energy 78 keV \rightarrow $\lambda=0.158$ Å)



w-ZrAlN phase grows with the 002 direction tilted 10-15 degrees to growth direction.

c-ZrN forms with the 111 direction tilted $\sim 10^\circ$ to the wurtzite 002 direction.

In situ WAXS → ZrAlN phase evolution during annealing

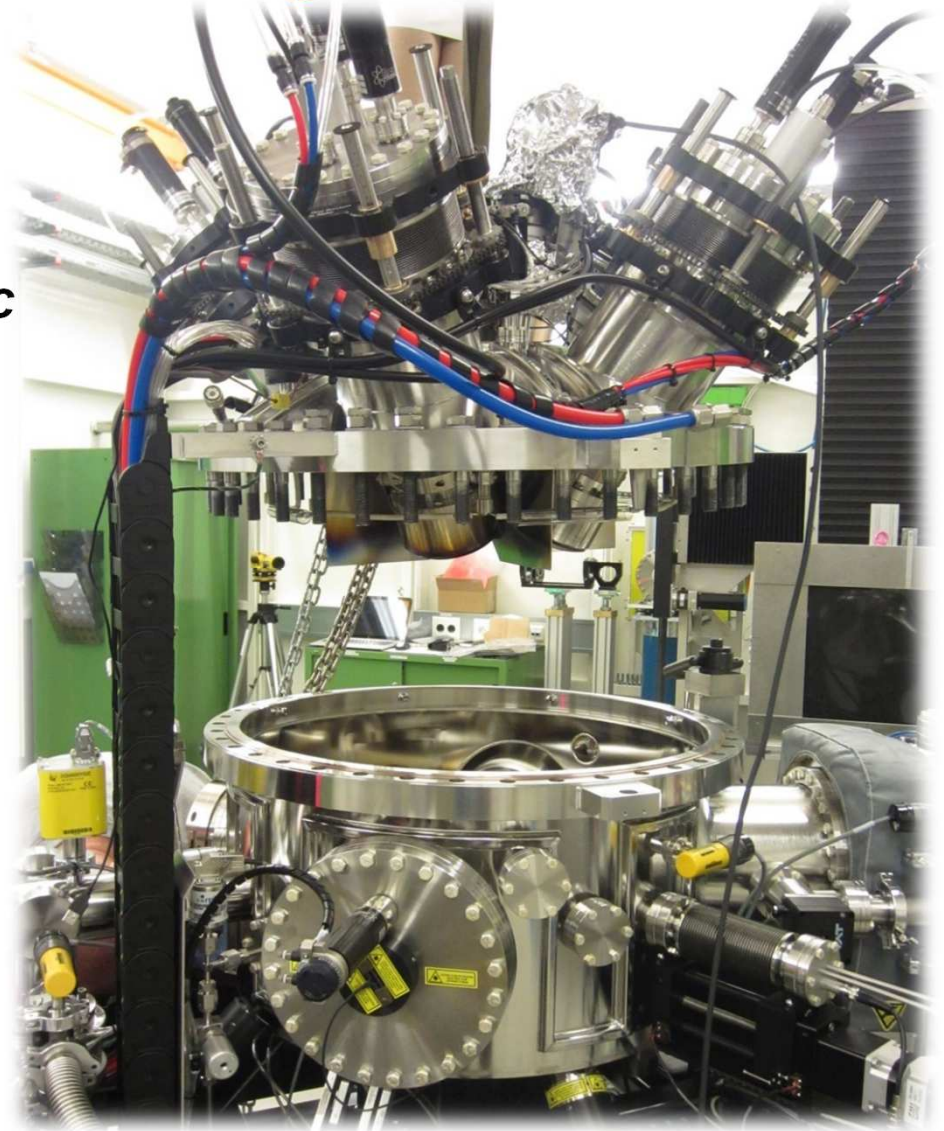


- Asymmetric broadening → w precipitates → wurtzite ZrAlN undergo spinodal decomp.
- c-ZrN nucleate and grow as soon as 1100 °C is reached.
- c-ZrN continue to grow at the expense of w-ZrAlN → **“over-ageing”**

UHV magnetron sputtering and cathodic arc deposition system for *In situ* high energy x-ray scattering during industrially-relevant thin film growth

Capabilities:

- **Film growth under real industrial conditions:**
 - Sources: Four 75 mm \varnothing **magnetrons**
Three 63 mm \varnothing **cathodic arc**
 - High substrate temperature $T_s > 1300$
 - High power \rightarrow high deposition rate
- **Materials research quality films**
 - Ultra High Vacuum
 - Epitaxial growth
 - Auxiliary *in situ* tools
- **Effective use of beamtime**
 - Minimal time for sample change
 - Minimal need of sample alignment
 - Full remote control
- **Off-beamline capability**
- **Portable under vacuum**

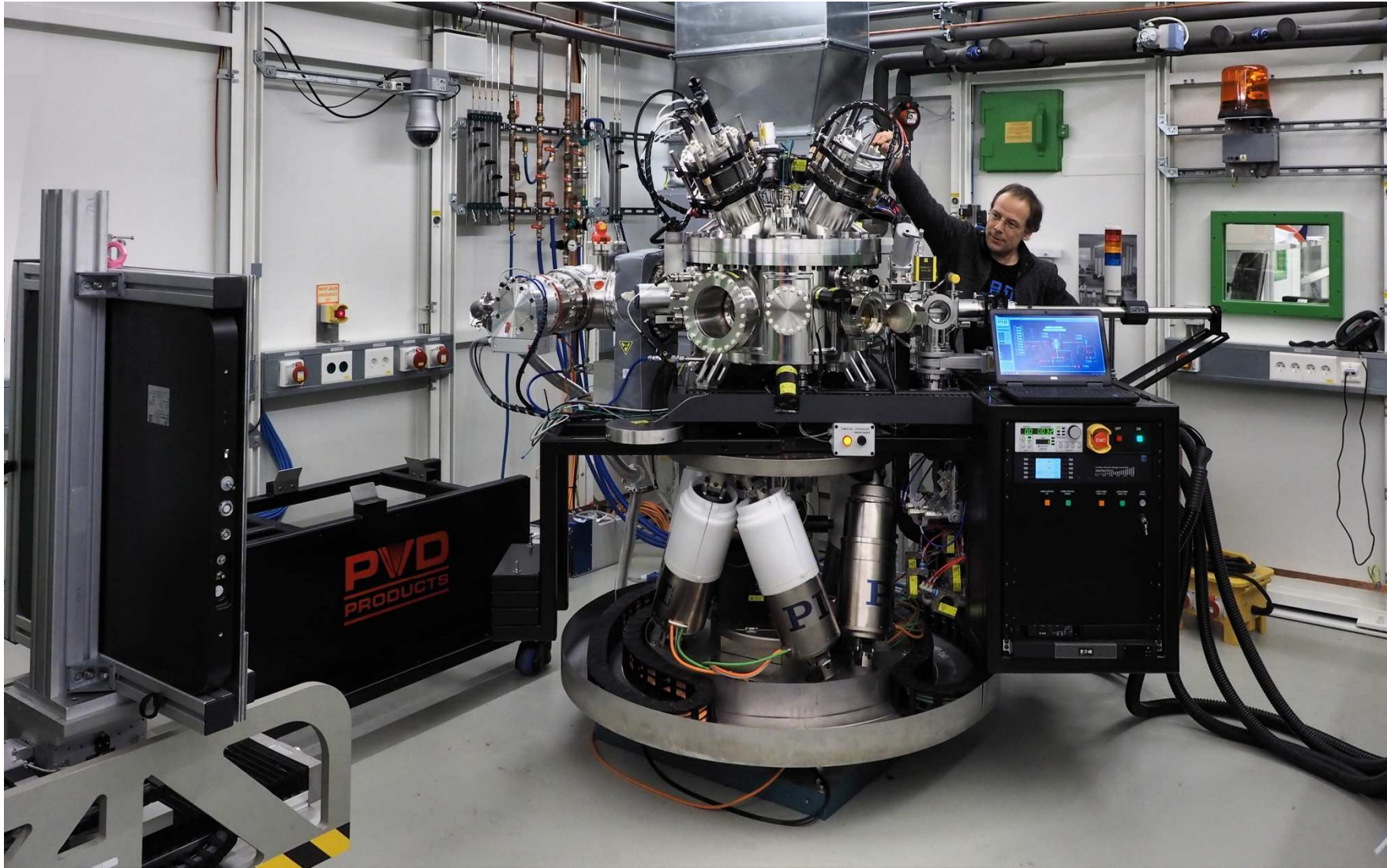


In situ UHV deposition chamber in the High Energy Materials Science beamline (HEMS)



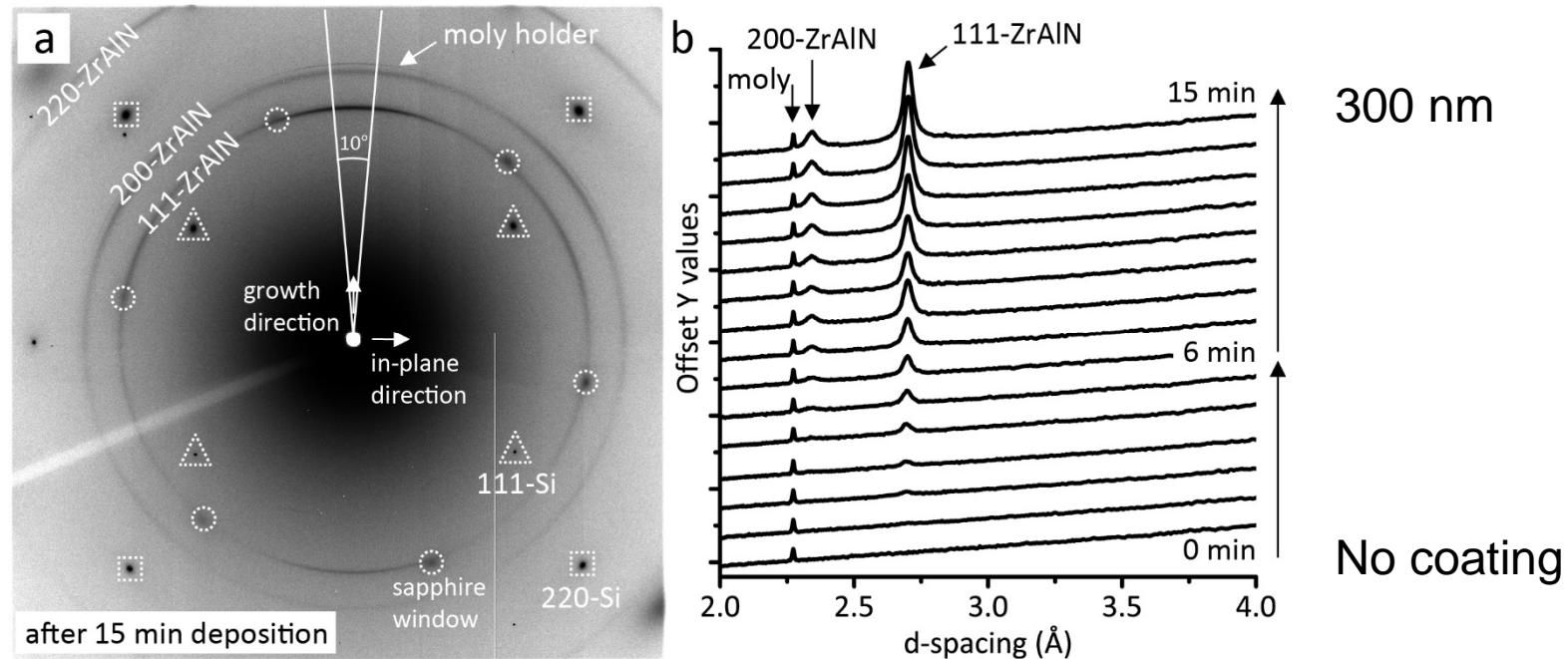
*Easy transport from off-beamline laboratory,
sealed for maintained vacuum up to 2 hrs.*

In situ UHV deposition chamber in the High Energy Materials Science beamline (HEMS)



Example of *in situ* XRD during growth

$\text{Zr}_{0.75}\text{Al}_{0.25}\text{N}$ reactive magnetron sputter deposition on Si (001)



$T_g = 700 \text{ }^\circ\text{C}$

Growth rate = 20 nm/min

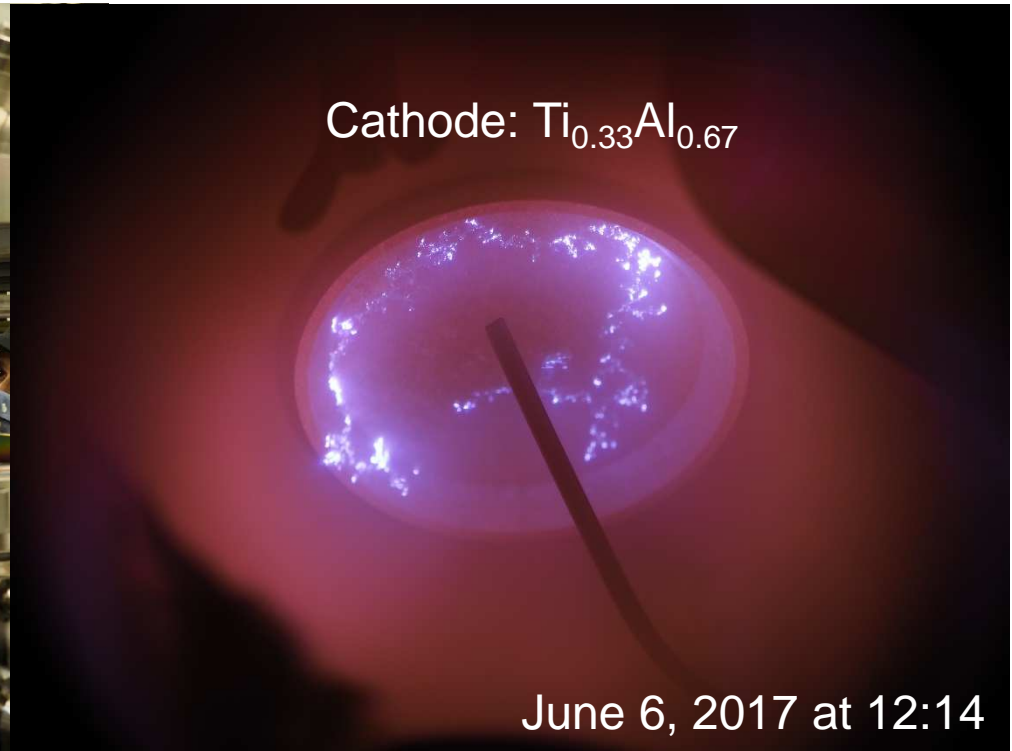
Working gas: 5 mTorr (10% N_2 /90% Ar)

Time-resolved growth experiments

- Industrial growth rates
- Phase evolution
- Stress & strain evolution
- Nucleation & growth?

Smoking Hot!

$\text{Ti}_{0.33}\text{Al}_{0.67}\text{N}$ cathodic arc deposition with *in situ* High Energy XRD



***Mounting dedicated chamber lid
with arc source
X-Cut design
UHV***

Running UHV arc source in the beamline

$I_{\text{cathode}} = 90 \text{ A}$

Gas: 34 mTorr N_2

Bias = - 30 V

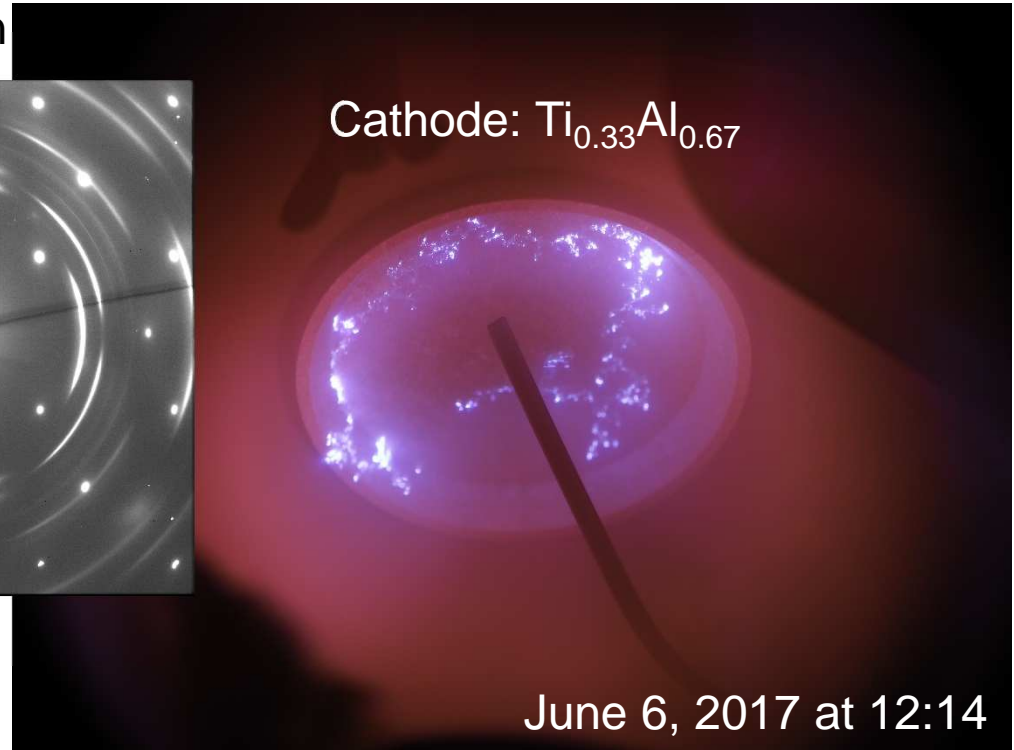
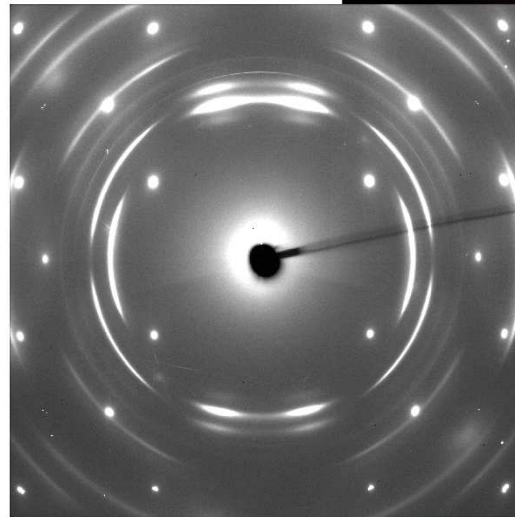
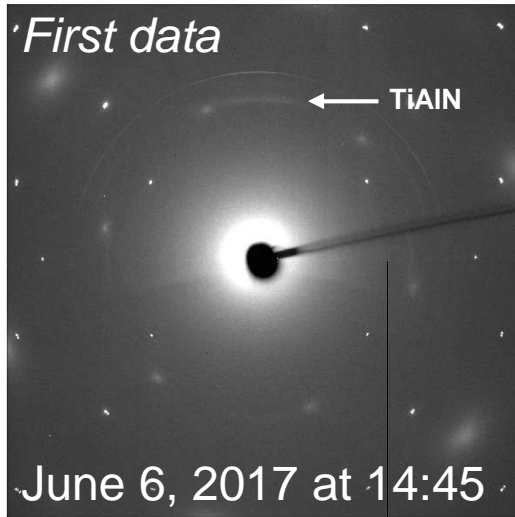
Temperature $\approx 400 \text{ }^\circ\text{C}$

Smoking Hot!

Ti_{0.33}Al_{0.67}N cathodic arc deposition with *in situ* High Energy XRD

Dep. time = 30 s

Dep. time 10 min



***In situ* WAXS of Ti_{0.33}Al_{0.67}N coating during cathodic arc deposition**

Never-before conducted experiment!

Running UHV arc source in the beamline

$I_{\text{cathode}} = 90 \text{ A}$

Gas: 34 mTorr N₂

Bias = - 30 V

Temperature $\approx 400 \text{ }^\circ\text{C}$

Death of thin films...



In operando high energy X-ray scattering during high-speed dry cutting

- **Industrial cutting conditions:**

- Vertical lathe
- High speed cutting >200 m/min
>750 rpm, 100 mm \varnothing workpiece
- Standard tool holder

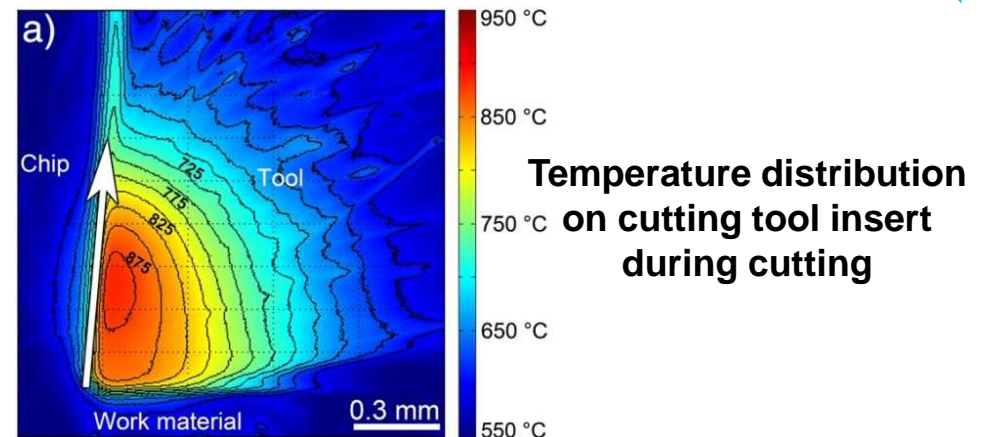
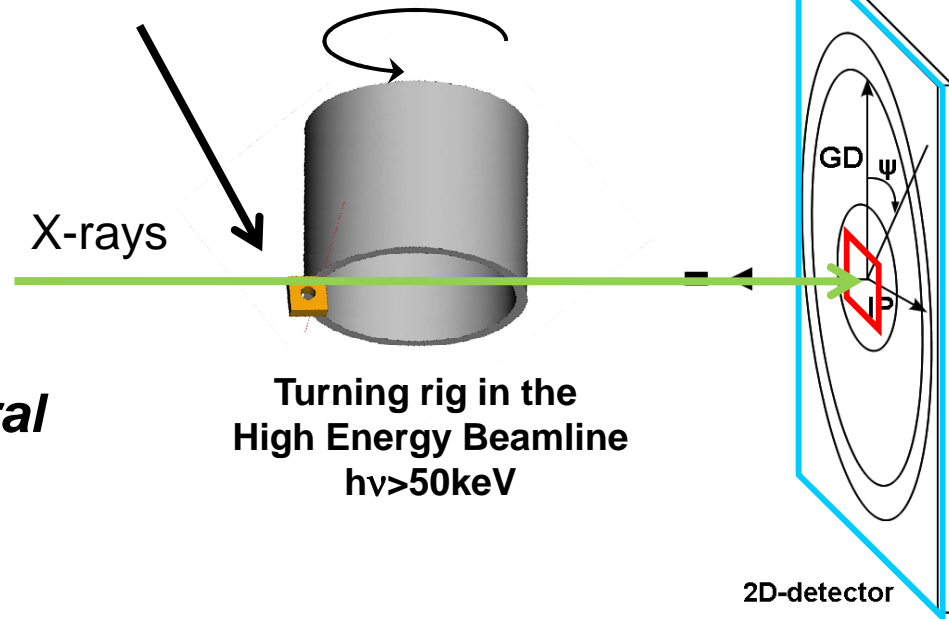
- **High d-spacing, spatial & temporal resolution**

- μm tool stability *during* cutting
- precision beam access
- Area detector compatible

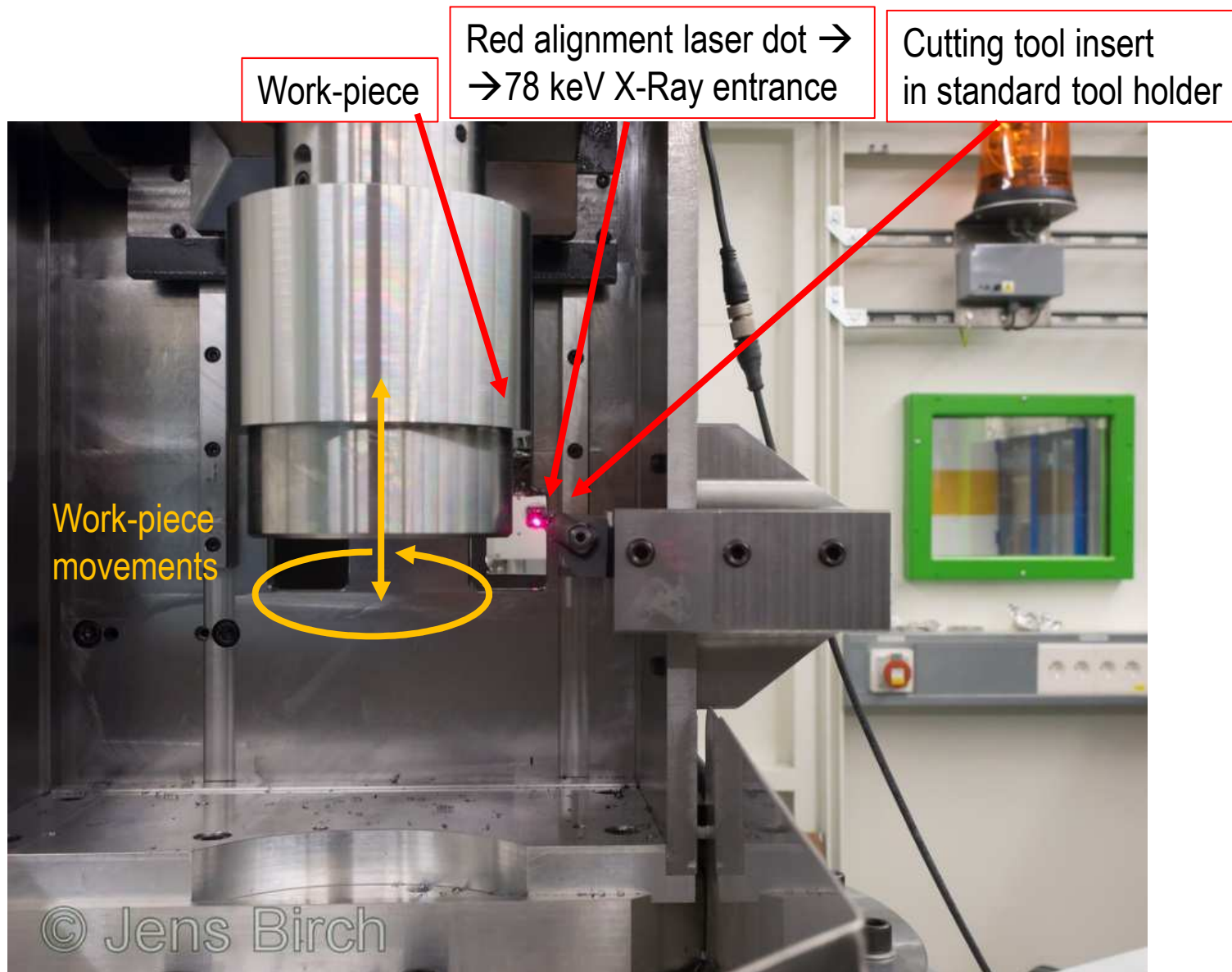
- **Efficient use of beamtime**

- Full remote control
- portable
- fast setup

Coated cutting tool insert



Turning operation at the beamline



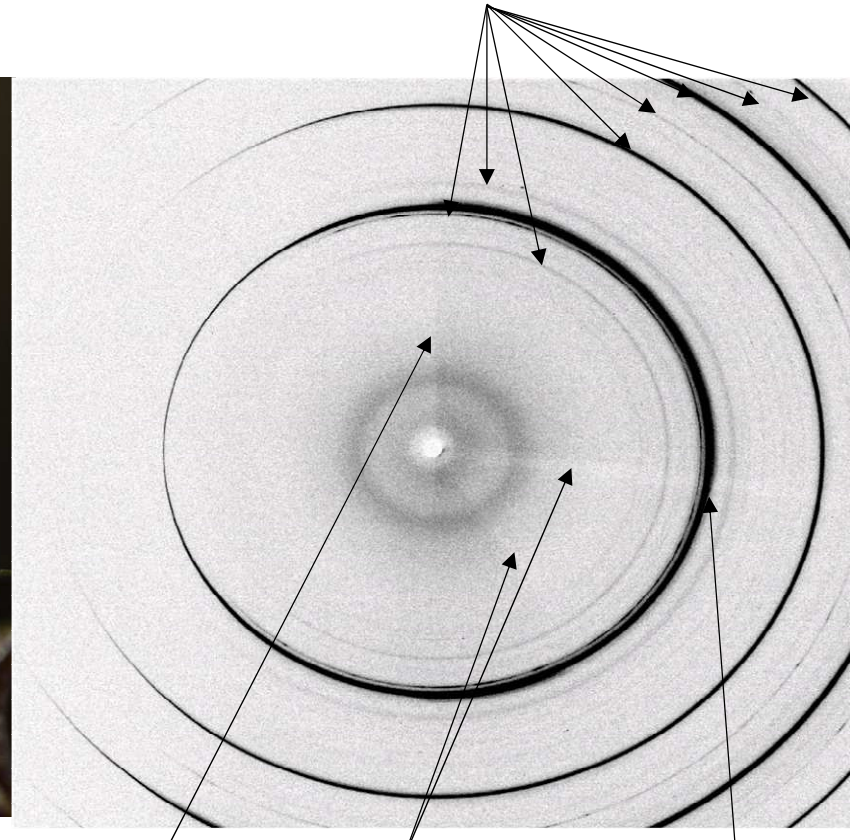
Turning operation at the beamline

Dry High-speed Turning Rig for In situ High-energy X-Ray scattering

© Jens Birch, Linköping University

Dry High-speed Turning – *In operando* XRD

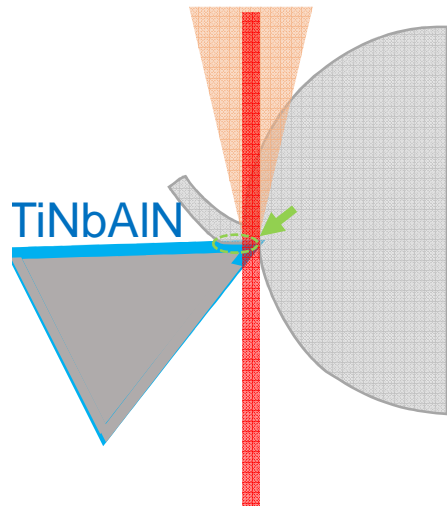
Dry High-speed Turning – Detailed view



X-Rays shadowed
by work piece

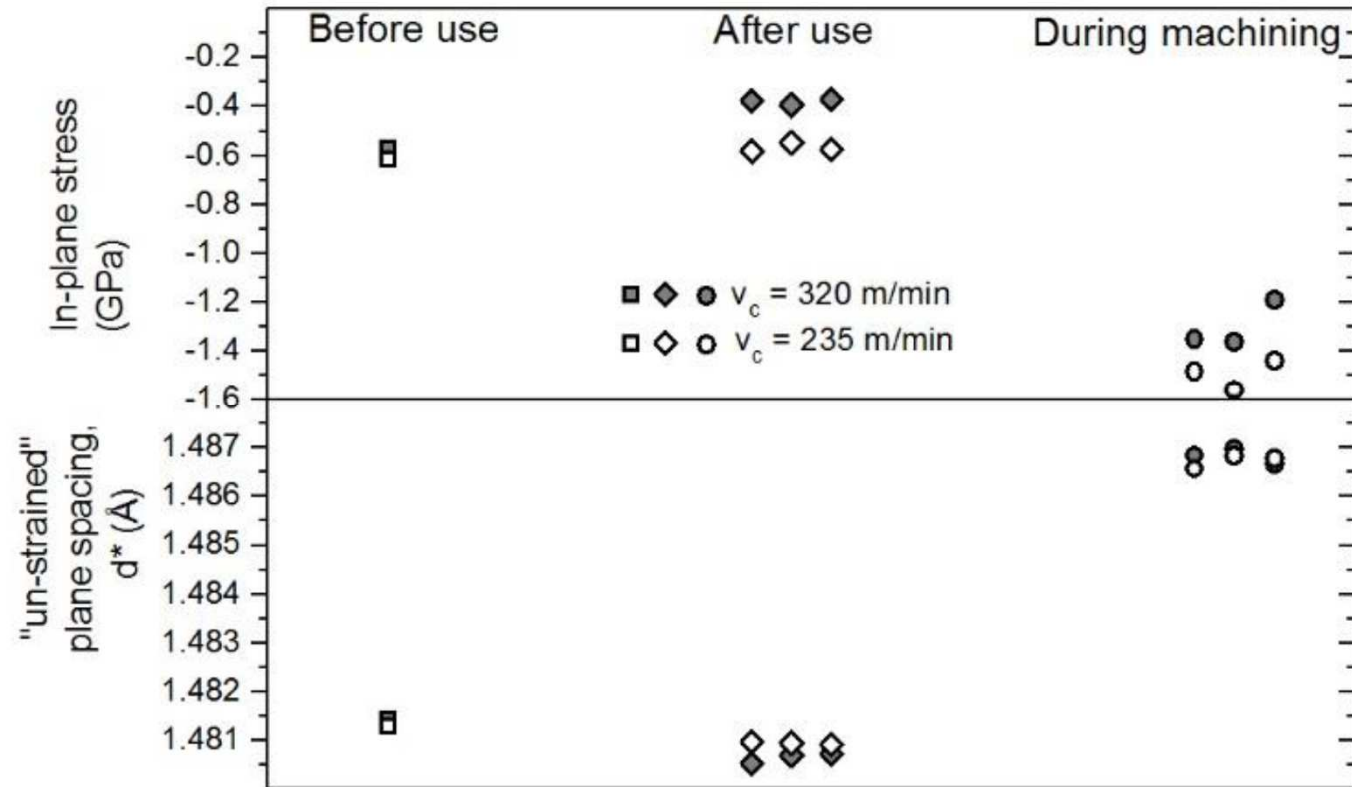
X-Rays shadowed
by tool

Diffraction by
the chips



$\text{Ti}_{0.22}\text{Nb}_{0.36}\text{Al}_{0.42}\text{N}$ coated onto WC-Co

Stress on tool edge - different cutting speeds

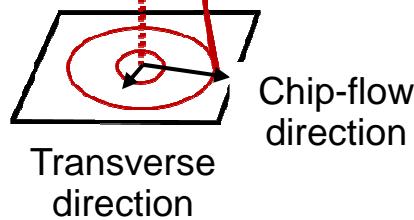
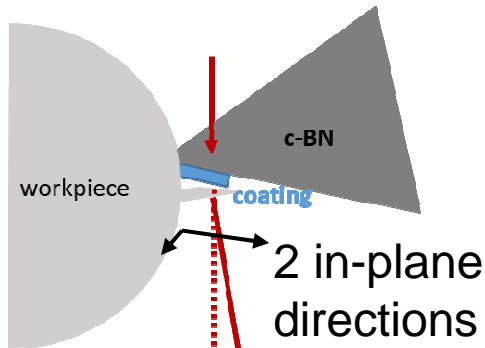


Lowest stresses during highest cutting speeds! → Paradox?

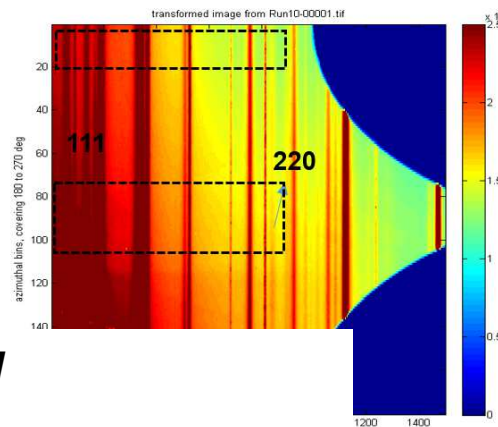
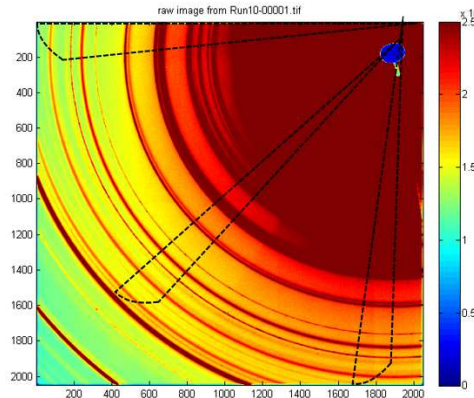
- Higher speed → Larger relaxation of intrinsic stresses
- Lower speed → Higher stress during machining (less relaxation)

Ti_{0.22}Nb_{0.36}Al_{0.42}N / c-BN, focussed beam

Preliminary results by Lina Rogström, Jens Birch et al.



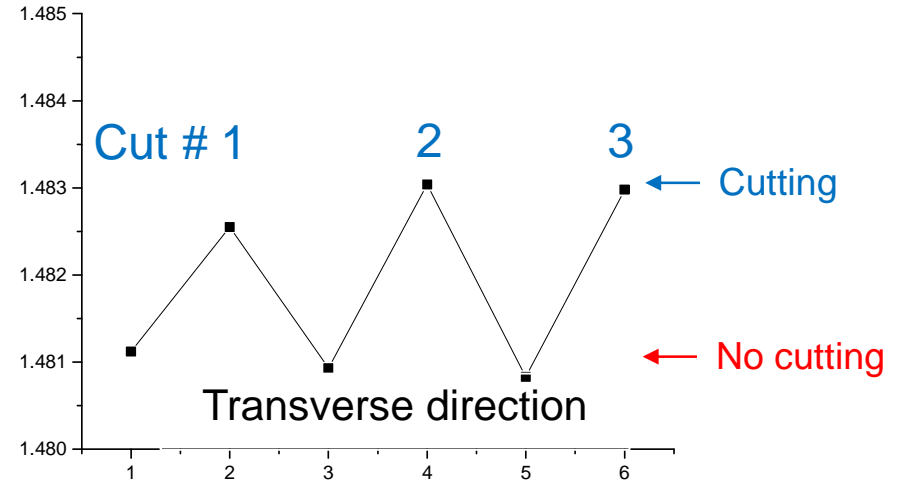
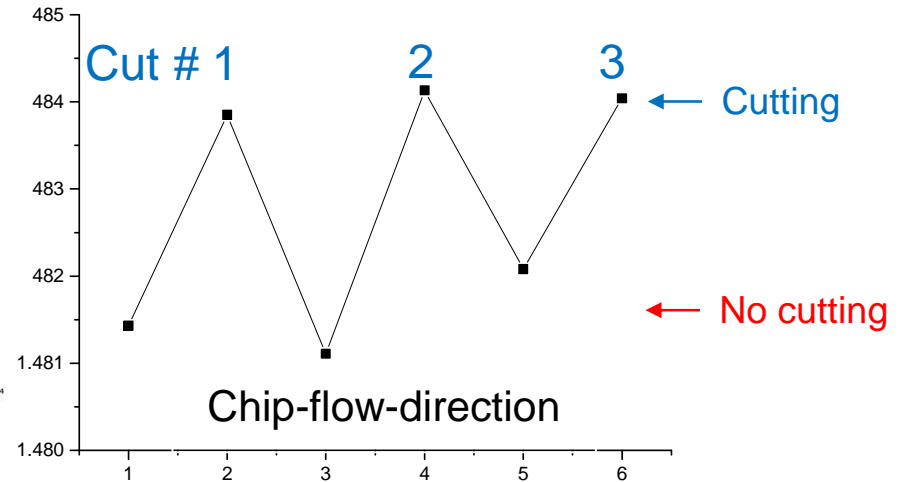
- **In-plane directional measurements**
- **~10 μm resolution**



Beam size = 30 x 5 μm²

Exposure time = 60 x 1 s (one exposure/length)

Rotation speed = 750 rpm



- Lattice expansion higher in chip-flow direction
→ not the usual biaxial state of stress
- Anisotropic plastic deformation of grains (Peak widths)

"A Lathe Like No Others"

EDGE Magazine 1, p.32-35 (2017) **SECO**
<https://www.secotools.com/#article/67498>



PHOTO: PER GROTH

Seco's Janne Eriksson and Mats Johansson Jöesaar – Unusual inspiration has led to brilliant development.

"Seco is the first metalworking company in the world that's doing it, and we now have a unique head start."



4 questions for



Jens Birch
Professor of Thin Film Physics at Linköping University in Sweden

SECO TOOLS AND LINKÖPING UNIVERSITY have worked together since 2010. PhD students have worked real-time with X-ray-technology studies of Seco's coatings.

Why does your institution work together with industry?

"Simply put, we are streamlining material process in order to better understand materials. It's important that our research is close to reality, and so it's only natural to pick up issues and problems from industry. As we produce the answers required, new knowledge often arises, which generates new questions and new ideas for new materials. It's a really fun way to work."

What challenges are you taking on with Seco Tools?

"We have worked together for a long time, among other things on real-time studies of the effects of pressure, temperature and other variables that affect the characteristics of the layers when they are used. We look at a few layers at a time to better understand each layer's characteristics and to be able to interpret the results that we see. The intensity of Petra III's X-rays offers unique opportunities in this area in

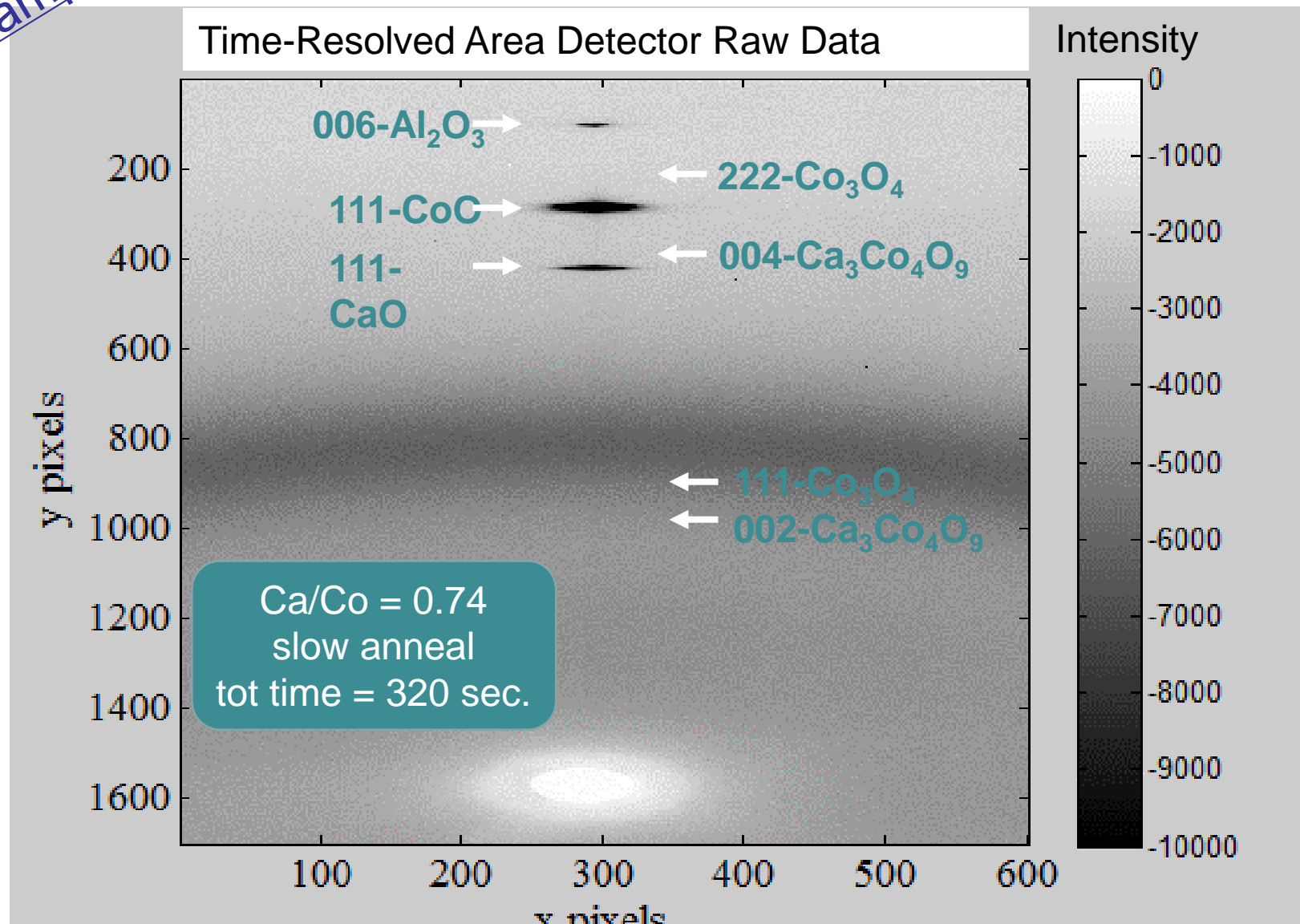
X-Cut Experiments 2012-2017 **Red=Spin-off projects**

1. Thermal stability of h-ZrAlN coatings (annealing chamber, EH3) [1]
2. Thermal expansion of TiAlN (annealing chamber, EH1) [2]
3. Growth kinetics of h-AlN in TiAlN coatings (annealing chamber, EH1, EH3) [3]
4. Thermal stability of c-TiZrAlN coatings (annealing chamber, EH1, EH3) [4]
5. Hardness in epitaxial TiAlScN alloy thin films and rocksalt TiN/(Al,Sc)N superlattices (annealing chamber EH1) [5]
6. Thermal stability of epitaxial cubic-TiN/(Al,Sc)N metal/semiconductor superlattices (annealing chamber EH1),[6]
7. Formation of Layered Cobaltate Ca₃Co₄O₉ by Annealing [7]
8. Thermal stability of HfN/ScN, ZrN/ScN, and Hf_{0.5}Zr_{0.5}N/ScN metal/semiconductor superlattices [9]
9. Growth of h-AlN in c-TiCrAlN coatings (annealing chamber, EH1)
10. Effect of grain size on decomposition of TiAlN (annealing chamber, EH1)
11. Phase transformations in Zr_{0.65}Al_{0.35}N/TiN (annealing chamber, EH1)
12. Phase identification in MS ZrAlN thin films (EH1)
13. Structure of MS ZrAlN/ZrN multilayers (EH1)
14. Oxidation behavior of c-TiCrAlN coatings (Lamp setup, EH1)
15. Phase transformations in 'stress-free' TiAlN grown by HiPIMS (annealing chamber, EH3)
16. Phase transformations in amorphous TiSiBN coatings (annealing chamber, EH3)
17. Phase evolution during growth of TiN/ZrAlN multilayers (Sputtering chamber, EH3)
18. Phase evolution during growth of ScAlN films (Sputtering chamber, EH3)
19. Dynamics of nucleation and growth of InAlN nanorods (Sputtering chamber, EH3)
20. Thermal stability of (CrAl)₂O₃ protective coatings on superalloys
21. Ti/Ni neutron mirrors
22. Cathodic arc in situ X-ray scattering during growth

Sum X-Cut Beamtime: 95 days

Spin-off
Example

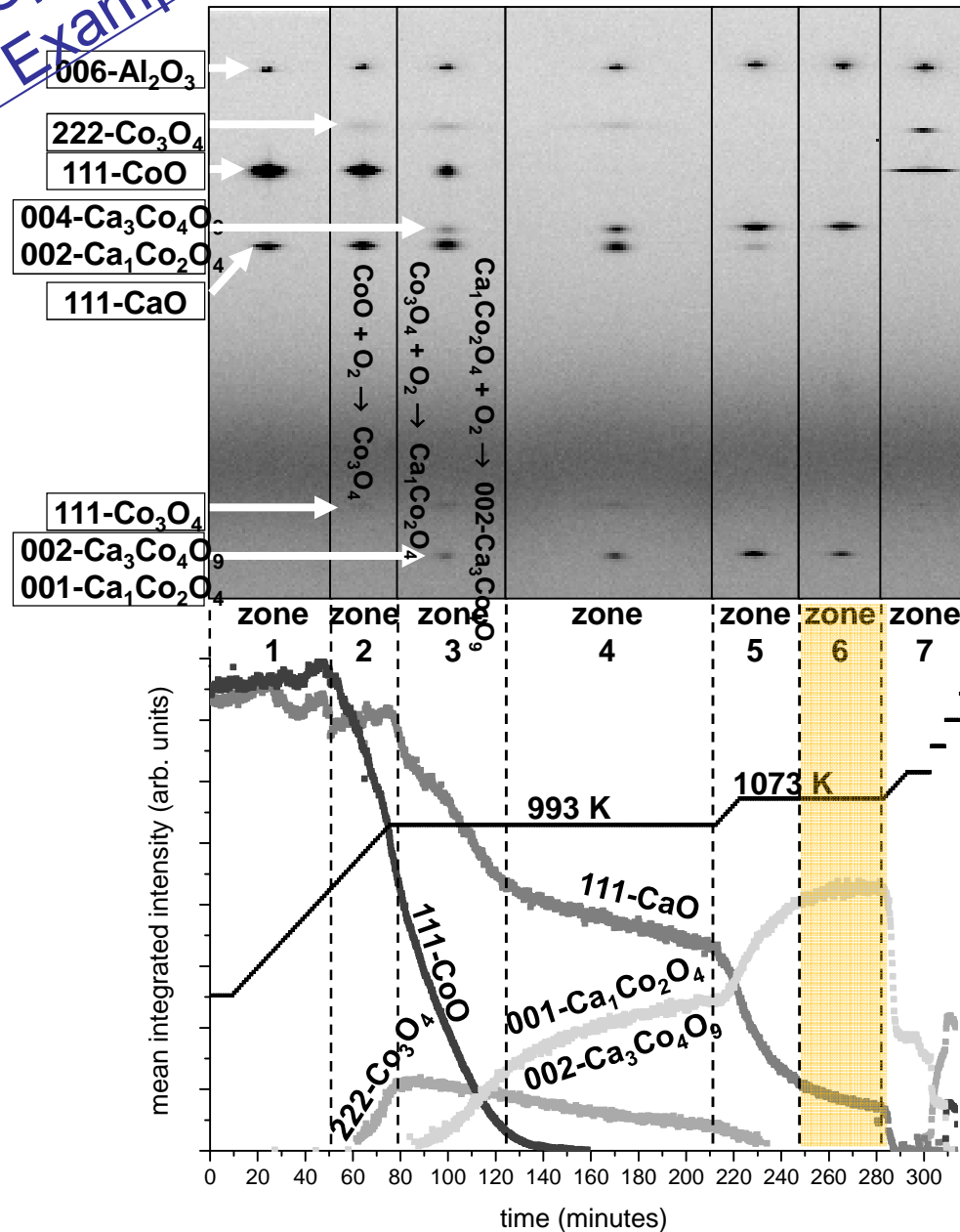
Synthesis of $\text{Ca}_3\text{Co}_4\text{O}_9$ thermoelectric coatings



B. Paul, J. L. Schroeder, S. Kerdsonpanya, N. V. Nong, N. Schell, D. Ostach, J. Lu, J. Birch, and Per Eklund, *Advanced Energy Materials* 1, 1400022 (2015)

Spin-off
Example

Synthesis of $\text{Ca}_3\text{Co}_4\text{O}_9$ thermoelectric coatings



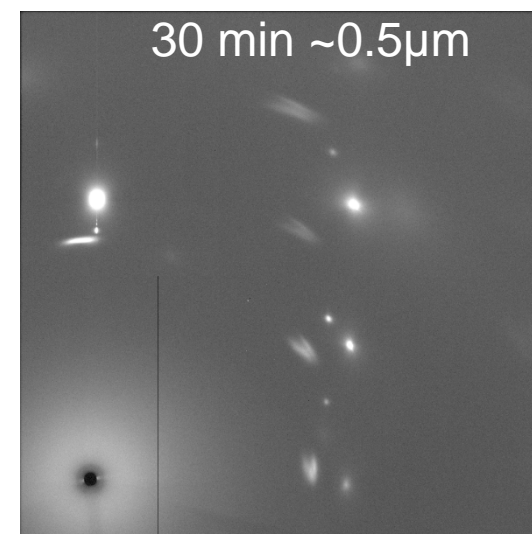
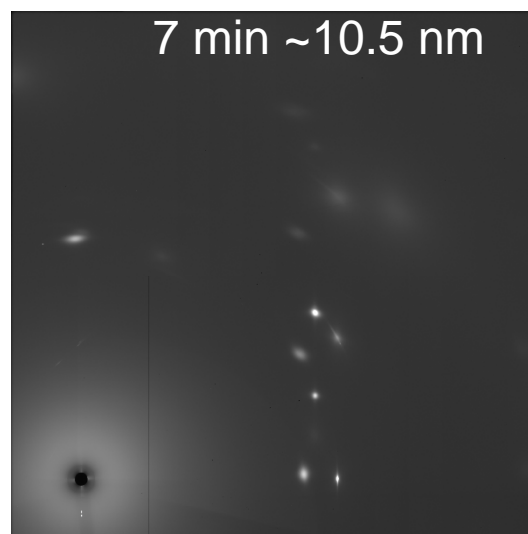
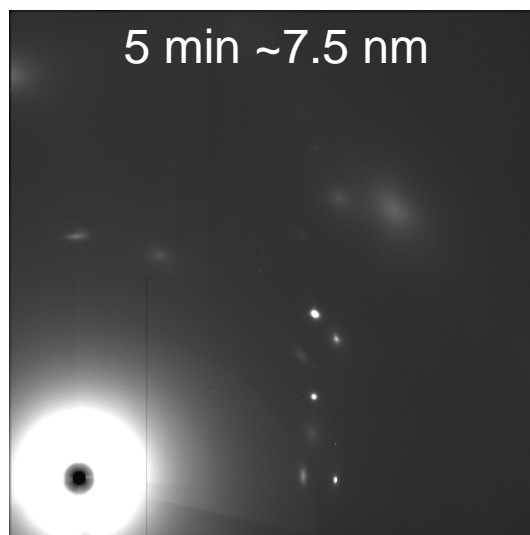
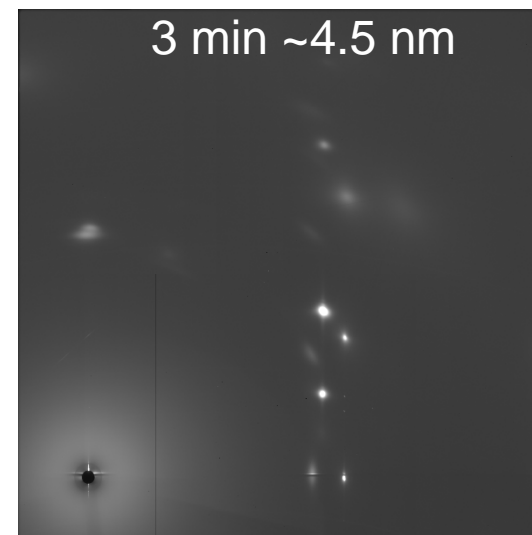
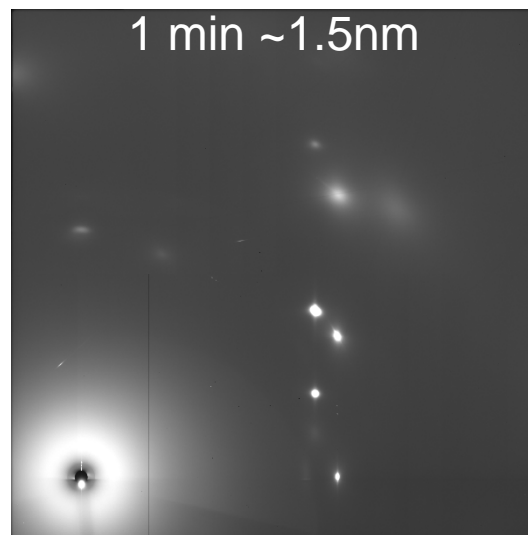
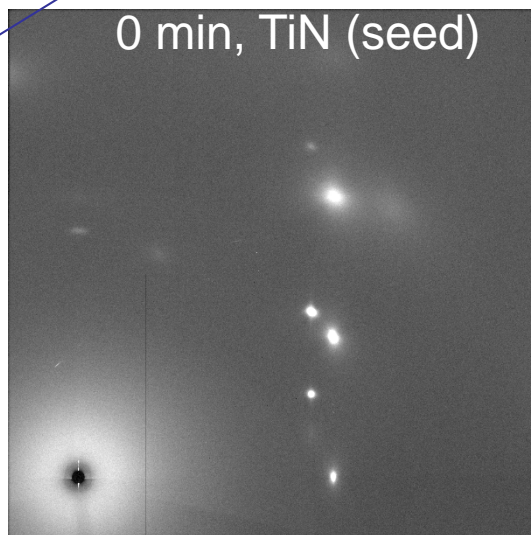
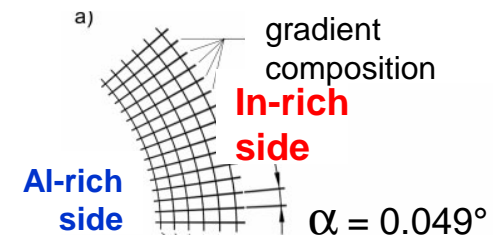
CaO and CoO transformation into the thermoelectric phase $\text{Ca}_3\text{Co}_4\text{O}_9$

- starts at 993 K
- complete: >1 hr at 1073 K (Zone 6)

B. Paul, J. L. Schroeder,
S. Kerdsongpanya, N. V. Nong,
N. Schell, D. Ostach, J. Lu,
J. Birch, and Per Eklund
Advanced Energy Materials 1,
1400022 (2015)

Spin-off
Example

In situ nucleation and growth of curved $\text{In}_x\text{Al}_{1-x}\text{N}$ nano-rods



Preliminary results by Ching-Lien Hsiao, Alexandra Serban, and Jens Birch

Summary of the RÅC X-Cut project

- **High-energy Synchrotron makes possible *in situ* time-resolved WAXS (and SAXS) for ...**
 - nucleation and growth
 - solid state reactions
 - nano-structure formation
 - degradation of tool coatings at real cutting conditions
 - study tool coatings
 - ... tool substrates
 - ... phase evolution in the chips
 - **...during industrial synthesis and use (cutting)**
- **Brought industry to the synchrotron**
- **Generated a lot of research & industrial collaboration proposals**
- **Generated a lot of spin-off projects**



The "X-Cut" team



Thin Film Physics Division:

Jens Birch (project leader)

Lars Hultman

Jeremy Schroeder

Muhammad Junaid

Naureen Ghafoor

Martin Magnusson

Ching-LienHsiao

Alexandra Serban

Erik Ekström

Nanostructured Materials Div.:

Magnus Odén

Lina Rogström

Y. H. Chen

Beamline P07 Petra III

Norbert Schell

Daniel Ostach

Andreas Schreyer

Martin Müller

Cutting Instrument

Mats Johansson

Rachid M'Saoubi

Mikael Fallqvist

Mats Carlsson

Janne Eriksson



**for financial
support**

Trends and Opportunities for Advanced Materials **and** **Techniques**

Norbert Schell & Jens Birch

09 June 2017 / DESY

National, international and industry **interest for current RAC-equipment at HEMS**

In operando lathe:

- Prof. Jens Gibmeier, Karlsruhe Institute of Technology
- Prof. Wolfgang Hintze*, Hamburg Technical University

Prof. Dr. J. Gibmeier, KIT, Karlsruhe

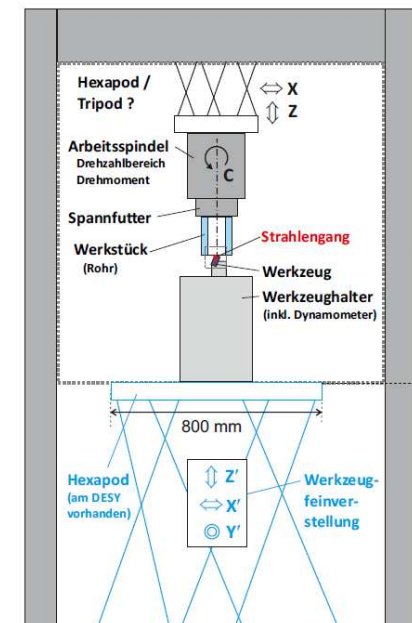
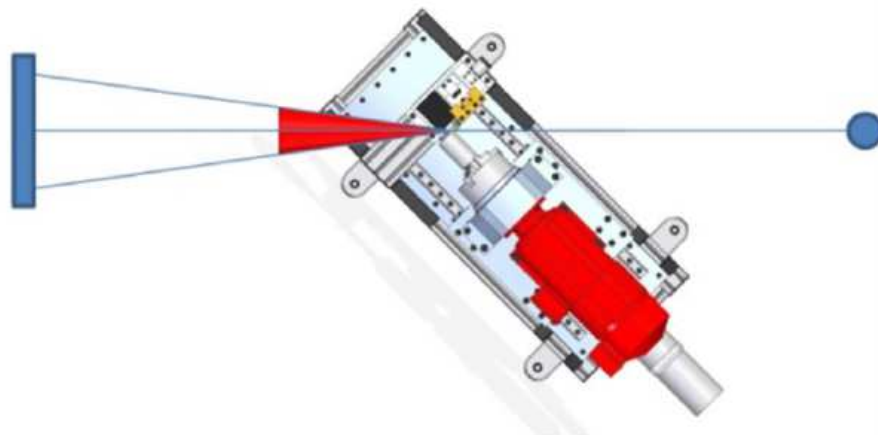
BUE (built-up edge) in SAE 1045 **steel** and
EN AW-5754 **Al-alloys** on **WC/Co** and **Si₃N₄**
substrates

Prof. Dr.-Ing. W. Hintze, TU Hamburg-Harburg,

Fa. Gühring (manufacturer of precision tools in Albstadt)

Cemented carbide (WC-Co), PCBW, mixed ceramics

fast 2D detector self-designed lathe X-ray source



National, international and industry *interest for current RAC-equipment* at HEMS



In operando lathe:

- Prof. Jens Gibmeier, Karlsruhe Institute of Technology
- Prof. Wolfgang Hintze*, Hamburg Technical University
- Prof. Jan-Eric Ståhl, Lund University

- SANDVIK Coromant



LUNDS UNIVERSITET
Lunds Tekniska Högskola



National, international and industry *interest for current RAC-equipment* at HEMS

***In operando* lathe:**

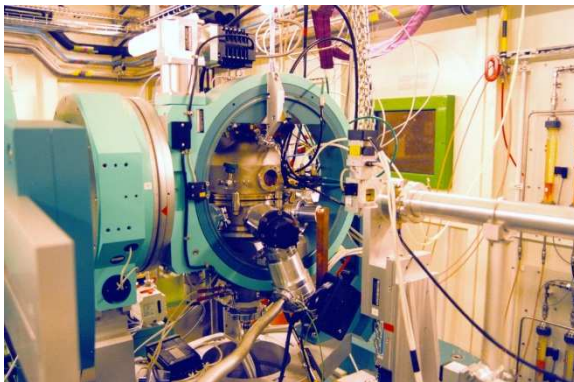
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- Prof. Wolfgang Hintze*, Hamburg Technical University
- Prof. Jan-Eric Ståhl, Lund University

- SANDVIK Coromant

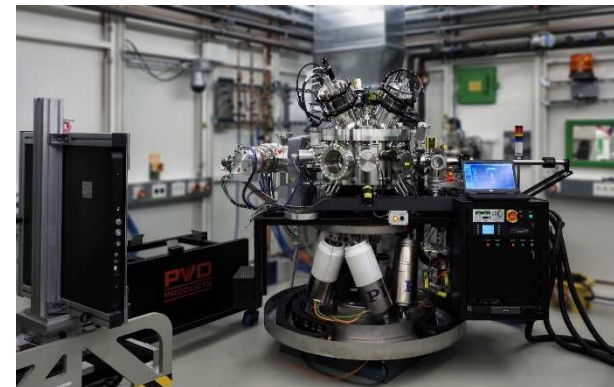


***In situ* sputter deposition system**

- Dr. Rui Martins*, Lissabon NOVA University



ROBL-CRG, ESRF
academic



HEMS, PETRA III
industry-relevant



National, international and industry *interest for current RAC-equipment* at HEMS



In operando lathe:

- Prof. Jens Gibmeier, Karlsruhe Institute of Technology
- Prof. Wolfgang Hintze*, Hamburg Technical University
- Prof. Jan-Eric Ståhl, Lund University

- SANDVIK Coromant



In situ sputter deposition system

- Dr. Rui Martins*, Lissabon NOVA University
- Dr. Erik Lindahl, Uppsala University

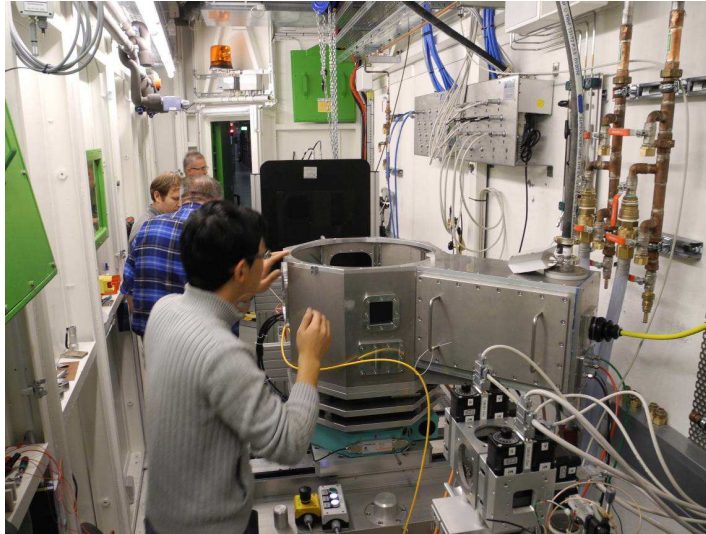
- PLANSEE*



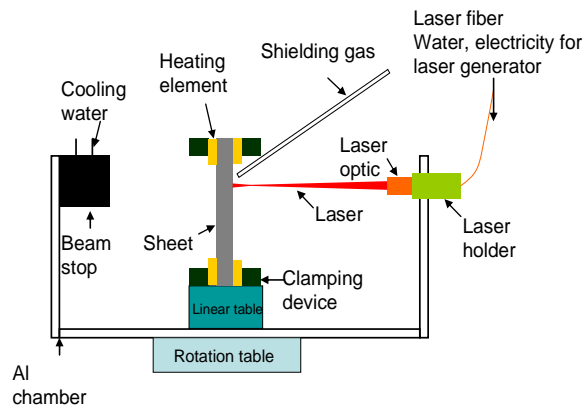
***Participated in joint grant proposals**



Future Trends: in-situ laser beam welding in-situ TIG (Tungsten Inert Gas) welding



CastoTIG 1401 DC

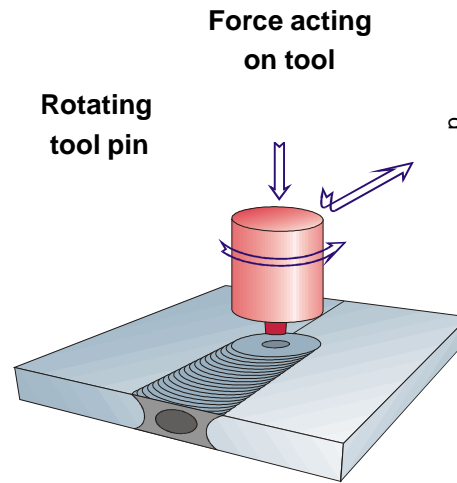
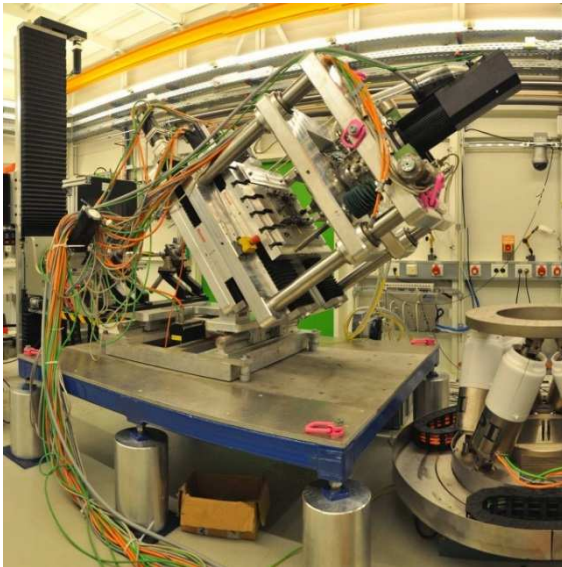


γ -TiAl attractive aero-space application, low density, good tensile properties at high temperature, high creep & oxidation resistance.

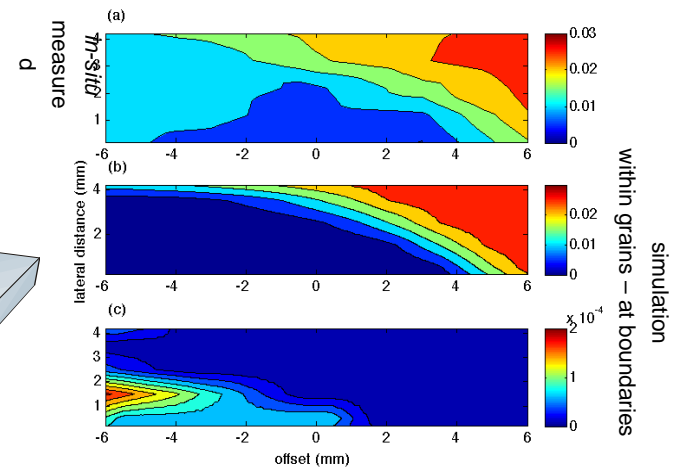
- voltage: 31.3 V
- **current (mean): 343 A (pulsed)**
- feed rate: 370 mm / min
- gas: CARGAL 1 (Ar/CO₂)
- LTT-wire-Ø: 1.6 mm
- LTT: 10% Cr / 10% Ni



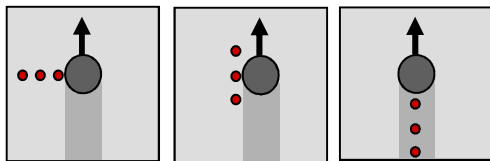
In-situ friction stir welding



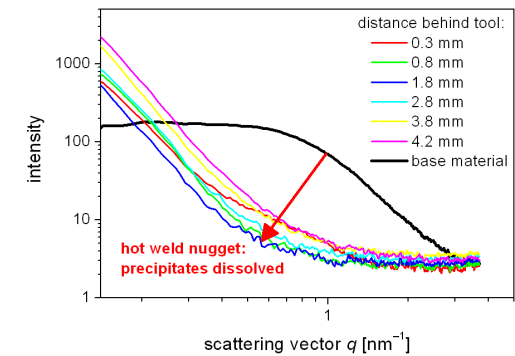
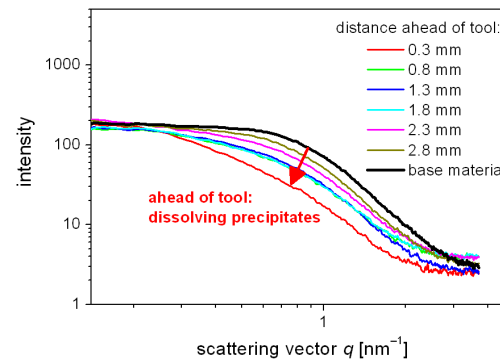
precipitate volume fraction
→ unique data for numerical models



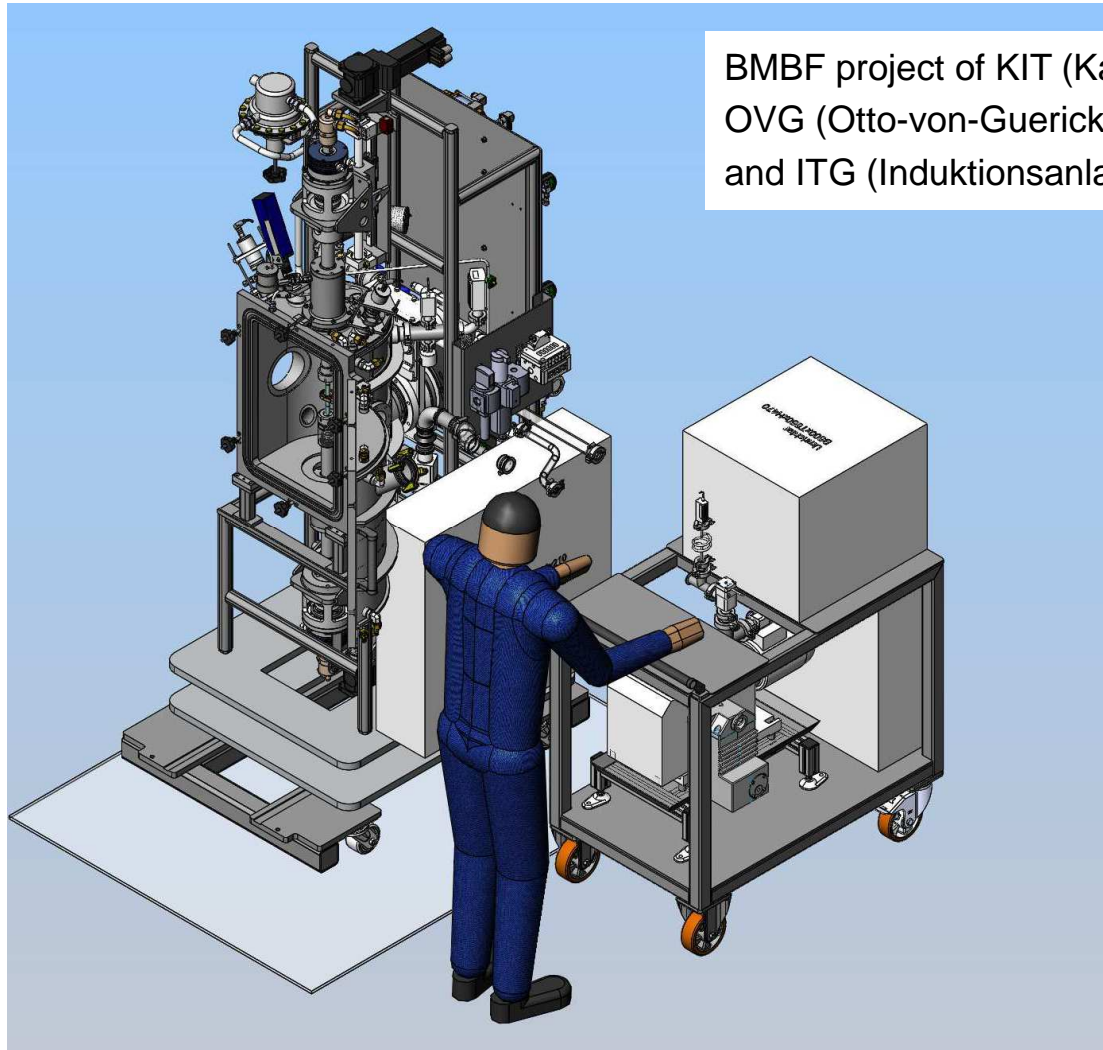
Highly versatile instrument for *in-situ* studies of:
different **FSW** methods, residual stress evolution, **precipitation forming**



Size & density distribution of precipitates by *in-situ* SAXS



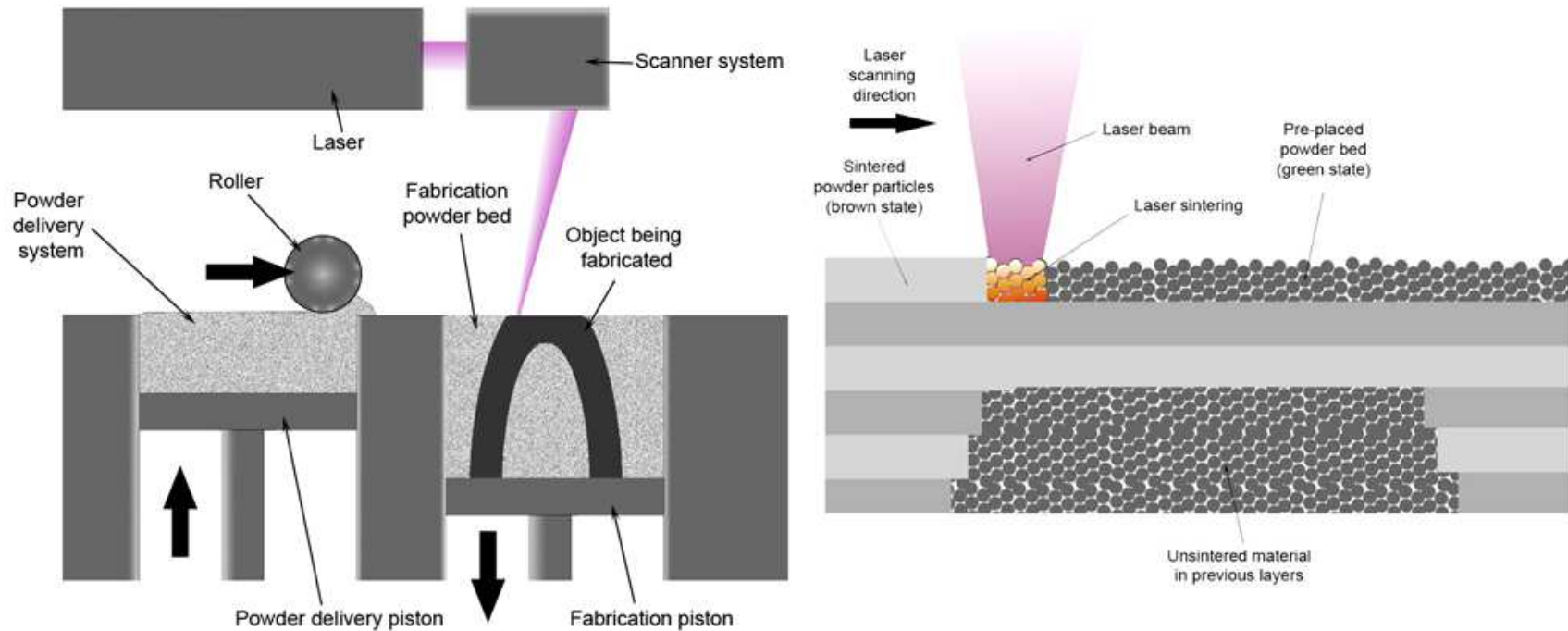
Future **Trends**: in-situ **directional zone melting**



BMBF project of KIT (Karlsruher Institut für Technologie), OVG (Otto-von-Guericke-Universität Magdeburg), HZG and ITG (Induktionsanlagen GmbH).

Insights to the solidification of the aligned microstructure and clarification of the influence of varying solidification parameters (e.g. solidification velocity, temperature gradient) on the microstructure evolution in novel materials with melting points exceeding 1000 °C, e.g. Fe-Al, Ti-Al, Nb-Si-Cr, Mo-Si-B, Mo-ZrB₂.

Future Trends: 3D Printing - SLM (Selective Laser Melting)



Conclusion

HEMS / GEMS

works hard to offer **equipment to a larger community**
offers **expertise in complex *in-situ* sample environments**
explores and is open to future ideas



Thank You

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